

<b>Notice of References Cited</b>	Application/Control No. 09/653,156	Applicant(s)/Patent Under Reexamination AGARWAL ET AL.	
	Examiner Yennhu B Huynh	Art Unit 2813	Page 1 of 1

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	B	US-6,309,923 B1	10-2001	Tseng, Horng-Huei	438/239
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	M	US-			

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**NON-PATENT DOCUMENTS**

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